

Substitute for form 1449/PTO (Revised 07/2007) INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>		Complete if Known	
		Application Number	10/589,222
		Filing Date	May 11, 2007
		First Named Inventor	Joseph M. DeSimone
		Art Unit	1635
		Examiner Name	To be Assigned
Sheet	1	of	7
		Attorney Docket Number	035052/339400

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Examiner Initials*	Cite No.	Document Number Number - Kind Code (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages of Relevant Figures Appear
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